IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re application of

In HATAKEYAMA

Group Art Unit.: 1752

250 1 9 2003

Serial No.: 10/003,288

Examiner: LEE, Sin J.

TC 1700

Filed: December 6, 2001

Title: AMINE COMPOUNDS, RESIST COMPOSITIONS AND PATTERNING PROCESS

REPLY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

In response to the Office Action mailed on September 10, 2003, please amend the claims as follows and consider the remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 16 of this paper.

CERTIFICATE OF MAILING

Signature:

12/16/2003 MAHMED1 00000058 10003288

01 FC:1201 02 FC:1202 86.00 OP 180.00 OP